



Attorney Docket No. 0756-2256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 09/774,637

Filed: February 1, 2001

For: BEAM HOMOGENIZER, LASER  
IRRADIATION APPARATUS,  
SEMICONDUCTOR DEVICE, AND  
METHOD OF FABRICATING THE  
SEMICONDUCTOR DEVICE

) Group Art Unit: 2815

) Examiner: Jose Diaz

) CERTIFICATE OF MAILING  
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Rose J. Diaz

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**AMENDMENT UNDER 37 C.F.R. §1.312**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please consider the following amendments and remarks in connection with the  
above-identified application.

**Amendments to the Specification** begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.